

DOCKET NO: VSEA 16-99

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Grant Kenji Larsen

Serial No:

09/676,548

Confirmation No:

2719

Filed:

September 29, 2000

For:

SURFACE STRUCTURE AND METHOD OF MAKING, AND

ELECTROSTATIC WAFER CLAMP INCORPORATING

SURFACE STRUCTURE

Examiner:

Stephen W. Jackson

Art Unit:

2836

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 20 day of January, 2004.

Cheryl Purcell

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Petition for Extension of Time

A three-month extension of time to January 20, 2004 (Monday after Holiday) is requested for response to the Examiner's Office Action of September 17, 2003.

The extension fee of \$950.00 may be charged to deposit account No. 50-0896. If the amount is insufficient, please charge deposit account No. 50-0896. A duplicate of this Petition is enclosed.

01/26/2004 YPOLITE1 00000092 500896 09676548

02 FC:1253

950.00 DA

Respectfully submitted,

Grant Kenji Larsen, Applicant

By:

Mark A. Superko, Reg. No. 34,027 Varian Semiconductor Equipment

Associcates, Inc. 35 Dory Rd.

Gloucester, Massachusetts 01930-2297

Telephone: (978) 282-5915

Docket No. VSEA 16-99